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Docket No. 50432-601

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
	:	
Minh Van NGO, et al.	:	Confirmation Number: 3500
	:	
Application No.: 10/617,451	:	Group Art Unit: 2812
	:	
Filed: July 11, 2003	:	Examiner: Lindsay, Jr., Walter Lee
	:	
For: PECVD SILICON-RICH OXIDE LAYER FOR REDUCED UV CHARGING		

SECOND AMENDMENT UNDER 37 C.F.R. § 1.116

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the Advisory
Action dated February 25, 2005 and in further response to the Office Action dated December 30,
2004, pursuant to the provisions of 37 C.F.R. § 1.116.